



PATENT Docket No. C 2397 COGG

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

Zech, et al.

Serial No. 10/075,726

Examiner: Unknown

Filed: 02/14/2002

Art Unit: 1743

Title: CHIP REACTORS HAVING AT LEAST TWO DIFFERENT

MICROREACTION CHANNELS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231, on 06-25-02 ______.

June 25, 2002

Date

Roll A. Stowl
Signature of certifier

= 3......

Rose A. Stowe

Typed or printed name of certifier

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Sir:

Transmitted herewith is an Information Disclosure Statement ("IDS") in the abovereferenced application, together with an IDC form listing all references cited and a copy of each reference.

No Office Action on the above-referenced application has been received by Applicant, and therefore no fee for submitting this IDS is believed to be due. However, the

Serial No. 10/075,726

Art Unit: 1743

Commissioner is hereby authorized to charge Deposit Account No. <u>50-1177</u> if any fee under 37 C.F.R. 1.17 is deemed necessary for the accompanying references to be considered by the Patent and Trademark Office.

Some of the references are neither in English nor cited in any accompanying English language version of a search report by another patent office, and therefore require a concise explanation of relevancy, as it is currently understood by the applicant, pursuant to 37 C.F.R. § 1.98(a)(3). This required explanation of relevancy is given in the specification of the above captioned application for the following references:

Reference Identification

Described in Specification at:

EP 0903174 A1

Page 1, Lines 10-12

Respectfully submitted,

TORSTEN ZECH, ET AL.

(Date)

AAŘÓN R. ETTELMAN

(Reg. No. 42,516)

Attorney for Applicants

Telephone: (610) 278-4930

Facsimile: (610) 278-4971 E-Mail: AARON.ETTELMAN@COGNIS-US.COM

Cognis Corporation, Patent Dept. 2500 Renaissance Blvd., Suite 200 Gulph Mills, PA 19406

ARE/ras

Enclosure: IDC (w/references)

A:\C2397.IDS.DOC

	/ & 300	Dook						
Form PTO-1449			Docket No. C 2397 COGG		Serial No. 10/075,726			
	TION DISCLOSURE CITATI	ON A 22		10/075,77	20			
INFORMA	TION DISCLOSURE CITATI	Oir Whhii	icant:					
			, et al.	Group:				
					Group: 1743			
				1743				
			TENT DOCUMENTS	Class	Cubalaga	Filing [)ata	
Examiner Initials*	Document Number	Date	Name	Class	Subclass	Filing Date if Approp.		
		***				<u> </u>		
		FORFICE	N PATENT DOCUMENTS		L			
	Desument Number	Date	Country	Class	Subclass	Transla	ation	
Examiner Initials*	Document Number	Date	Country	Olass	Cabolaco	Yes		
miliais	0 903 174 A1	3/24/99	Europe			Abstract		
						<u> </u>	 	
OTHER	DOCUMENTS (Including Autho	r, Title, Date	, Pertinent Pages, Volume-I	ssue No., P	ublisher, City	where pub	lisnea	
	nge 44-55		al Devices", SCIENTIFIC AM					
	Burns, et al., "Developmer	nt Of A Micro	reactor For Chemical Produ	iction", Tran	s IChemE, V	ol. 77, Part	A,	
	(May, 1999), pgs. 206-211							
		· ·····						
Examiner		Date C	Considered					

^{*} EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.